

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang Art Unit : 2814
Serial No. : 09/362,808 Examiner : Shrinivas H. Rao
Filed : July 28, 1999 Conf. No. : 7320
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT ACCOMPANYING RCE

Please amend the application as indicated on the following pages:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.